

INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

December 19, 2024

IGI Report Number

LG669482093

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

ROUND BRILLIANT

Measurements

7.78 - 7.80 X 4.73 MM

GRADING RESULTS

Carat Weight

1.76 CARAT

Color Grade

E

Clarity Grade

VS 1

Cut Grade

IDEAL

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT


Symmetry

EXCELLENT

Fluorescence

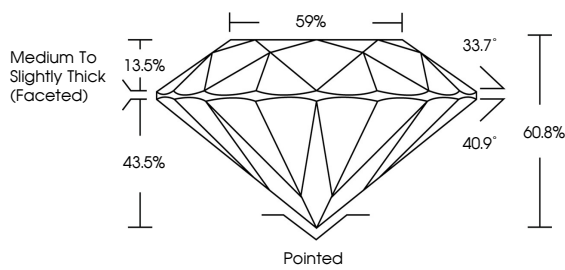
NONE

Inscription(s)

 LG669482093

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

PROPORTIONS



Medium To Slightly Thick (Faceted)


59%

33.7°

40.9°

60.8%

Pointed



Sample Image Used

COLOR

D

E

F

G

H

I

J

Faint

Very Light

Light

CLARITY

IF

VS¹⁻²

VS¹⁻²

SI¹⁻²

I¹⁻³


Internally Flawless

Very Very Slightly Included



Very Slightly Included

Slightly Included

Included




IGI



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
Symmetry

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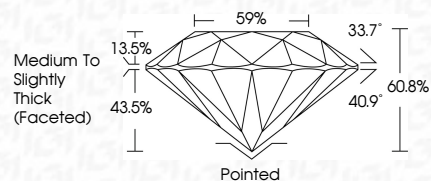
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
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